

211909US-2 CIP



RECEIVED

OCT 24 2003

TC 1700

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

ATSUMI YAMAGUSHI, ET AL.

: EXAMINER: DEO, DUY VU  
NGUYEN

SERIAL NO: 09/915,396

:

RCE      HEREWITH  
FILED:

: GROUP ART UNIT: 1765

FOR:      METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

**AMENDMENT**

ASSISTANT COMMISSIONER FOR PATENTS  
ALEXANDRIA, VA 22313

SIR:

In response to the Office Action dated July 24, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Drawings** begin on page 9 of this paper and include attached replacement sheets (4).

**Remarks/Arguments** begin on page 10 of this paper.